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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99) | Application Number | | 10800409 |
| | Filing Date | | 2004-03-11 |
| | First Named Inventor | Wu et al. | |
| | Art Unit | 1762 | |
| | Examiner Name | Chen, B. | |
| | Attorney Docket Number | NOVLP098/NVLS-2907 | |

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| 5 | 20060040507 | | 2006-02-23 | Mak et al. | |
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| 7 | 20060105566 | | 2006-05-18 | Waldfried et al. | |
| 8 | 20040018717 | | 2004-01-29 | Fornof et al. | |
| 9 | 20040213911 | | 2004-10-28 | Misawa et al. | |
| 10 | 20040249006 | | 2004-12-09 | Gleason et al. | |
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| | 5 | Niu et al., "Methods for Improving the Cracking Resistance of Low-K Dielectric Materials," Novellus Systems, Inc., Appl. No. 11/376,510, filed March 14,2006, pages 1-28. [NOVLP099D1/NVLS-2896D1] | <input type="checkbox"/> |
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| 10 | U.S. Notice of Allowance and Fee Due mailed December 20, 2005, from U.S. Application No. 10/860,340. [NOVLP099/NVLS-2896] | <input type="checkbox"/> |
| 11 | Wu et al., "PECVD Methods for Producing Ultra Low-K Dielectric Films Using UV Treatment," Novellus Systems, Inc., Appl. No.11/608,056, filed December 7, 2006, pages 1-34. [NOVLP196/NVLS-3238] | <input type="checkbox"/> |
| 12 | Wu et al., "Methods for Improving Performance of ODC Films with Dielectric Constant < 4.0," Novellus Systems, Inc., Appl. No. 11/693,661, filed March 29, 2007, pages 1-46. [NOVLP200/NVLS-3269] | <input type="checkbox"/> |

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| Signature | /Denise S. Bergin/ | Date (YYYY-MM-DD) | 2007-09-10 |
| Name/Print | Denise S. Bergin | Registration Number | 50581 |

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